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AMENDMENT IN RESPONSE TO (OFFICE ACTION DATED JANUARY 24, 2003)

13/B

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Heikyung Min et al.

Appln. No.: 10/032,930

Filed: October 29, 2001

For: SEMICONDUCTOR STRUCTURE FOR

REDUCING SURFACE ZENER DRIFT USING TITANIUM-BASED METALLURGY

(as amended)

Group Art Unit: 2818

Examiner: Dung A. Le

AMENDMENT (IN RESPONSE TO OFFICE

ACTION DATED JANUARY 24, 2003)

RECEIVET IPR-2 2013 TC 2800 HAIL ROOT

Commissioner for Patents Washington, D.C. 20231

Dear Sir:

In response to the Official Action mailed January 24, 2003, please amend the above-identified application as follows:

In the Title

Please amend the title in all instances to read as follows:

SEMICONDUCTOR STRUCTURE FOR REDUCING SURFACE ZENER DRIFT USING TITANIUM-BASED METALLURGY

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service, postage prepaid, in an envelope, addressed to Box Non-Fee Ama, Commissioner for Patents, Washington D.C. 20231-9999 on March 24, 2003.

Dated: 03-24-03